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Contents

- vii Authors
- xi Symposium Committee
- xiii Conference Committee
- xv Introduction
- xvii Conference Organizers

OPTOELECTRONIC MEASUREMENT TECHNOLOGY AND SYSTEM

11439 02	Design and research of phase-locked loop for infrared laser ranging system [11439-3]
11439 03	Surface profile measurement based on continuous wavelet transform in line-scan dispersive interferometry (Invited Paper) [11439-4]
11439 04	Defective samples simulation through neural style transfer for automatic surface defect segment [11439-6]
11439 05	Micro-vibration calibration system based on laser Doppler [11439-7]
11439 06	3D extrinsic joint calibration of 3D-Flash-LiDAR and camera system [11439-11]
11439 07	Sub-pixel wavelength calibration of spectrometer [11439-12]
11439 08	Design of chip character recognition system based on neural network [11439-13]
11439 09	Indoor point cloud recognition with deep convolutional networks [11439-14]
11439 0A	An on-site calibration method for on-line detection system of wheelset geometric parameters [11439-15]
11439 OC	Study on non-phase-shifting phase retrieval methods for interferogram with large phase gradient [11439-20]
11439 OD	High-bandwidth angular jitter measurement for acquisition, tracking and pointing system [11439-21]
11439 OE	Compact high-stability and low-nonlinearity heterodyne grating interferometer [11439-23]
11439 OF	A new pose measurement method based on microlens arrays [11439-25]

11439 0G	A novel image points matching method by intersecting into space for close-range photogrammetry [11439-26]
11439 OH	Fast deflectometric measurement of freeform surfaces for ultra-precision optical manufacturing (Invited Paper) [11439-27]
11439 01	Thermostatic chamber for Doppler broadening temperature measurement [11439-28]
11439 OJ	Performance analysis of software-based methods to expand the dynamic range of Shack- Hartmann wavefront sensor [11439-31]
11439 OK	Vertex radius of curvature fabrication error measurement of aspheric surface based on aberration analysis in partial compensation interferometry [11439-34]
11439 OL	Laser displacement sensor optimization for space structure vacuum thermal test [11439-36]
11439 OM	Non-orthogonal shafting laser sensor for trans-scale three-dimensional measurement [11439-38]
11439 ON	The calculating method of minimal-distance between aero-engine pipelines by using optoelectronic measurement system [11439-39]
11439 00	Accuracy assessment of tissue polarimetric properties based on Mueller matrix images decomposition [11439-40]
11439 OP	Face 3D measurement by phase matching with infrared grating projection [11439-42]
11439 OQ	A fast and cost-efficient technique for estimating feedback strength parameter C in laser self- mixing interferometry [11439-43]
11439 OR	Study on infrared collimation heating technology in thermal vacuum tests [11439-44]
11439 OS	Location of circular retro-reflective target based on micro-vision [11439-47]
11439 OT	Research on the application of indoor GPS in aircraft assembly [11439-49]
11439 OU	An absolute displacement measurement method of simple graphic decimal shift encoding [11439-50]
11439 OV	Femtosecond pulse laser distance and angle interferometer [11439-52]
11439 OW	Design and test of a multi-line structured light projector [11439-53]
11439 OX	Absolute distance measurement by dispersive interferometry using an electro-optic comb [11439-55]
11439 OY	Design and performance characterization of a quartz crystal micro-retarder array [11439-56]

11439 OZ	Global calibration method for non-overlapping cameras based on mobilephone screens in defocus scene [11439-57]
11439 10	A method of MRTD parameter measurement based on CNN neural network [11439-59]
11439 11	Statistical characteristics analysis of global specific humidity vertical profile [11439-60]
11439 12	Influence of nonlinear error on measuring accuracy for a dual-frequency heterodyne interferometer using a polarization maintaining fiber [11439-61]
11439 13	Off-axis catadioptric partial compensator design for interferometric measurement of optical freeform surface [11439-62]
11439 14	A new automatic hand-held laser rangefinder verification system [11439-63]
11439 15	Research on calibration technology of comprehensive performance parameters of mid-far infrared space load [11439-66]
11439 16	Design and research of automatic cylinder calibration system based on digital image processing technology [11439-67]
11439 17	Design and simulation on compact type of LED light source radar system for aerosol detection [11439-68]
11439 18	A multi-dimensional evaluation method of the angle measurement performance for the transmitter [11439-69]
11439 19	A new methodology for evaluating profile and position errors of blade based on parameter priority [11439-70]
11439 1A	Research on calibration method of hybrid Body-in-White online measurement system [11439-75]
11439 1B	A noncontact full-field flatness measuring system based on fringe projection [11439-80]
11439 1C	Theoretical model on underwater sound detection based on laser heterodyne method [11439-81]
11439 1D	The research of optical fiber sensor calibration based on acoustic sensor calibration system [11439-82]
11439 1E	The temperature field measurement method by using schlieren method for aircraft engine [11439-84]
11439 1F	Machine vision based recognition and integrity inspection of printing characters on food package [11439-86]
11439 1G	A spectrally tunable monochromatic integrating sphere photon source for spectral photon radiance responsivity calibration [11439-87]
11439 1H	Automatic segment assembly in shield method using multiple imaging sensors [11439-88]

- 11439 11 Robust 6DOF measurement for non-overlapping multi-camera systems based on uncertaintyweighted space resection [11439-96]
- 11439 1J Research on the effects of charge transfer efficiency on X-ray energy spectra taken with CCDs [11439-98]
- 11439 1K Coordinate evaluation using three-dimensional reference standard [11439-100]
- 11439 1L **Temperature measurements by infrared thermal imaging system in thermal vacuum test** [11439-102]
- 11439 1M Based on EMCCD imaging system [11439-103]
- 11439 1N A research on extraction of meter line of steel tape image based on Gabor transformation [11439-104]
- 11439 10 **Research on measurement optical axis eccentricity and fitting method of aspheric mirror** [11439-105]
- 11439 1P A fiber-based photodetector linearity measurement system from classic to single photon level [11439-107]
- 11439 10 A technology of absolute distance measurement based on multi-wavelength self-mixing interferometry of a three-wavelength optical fiber laser [11439-109]
- 11439 1R Volume measurement system of large vertical energy storage tank based on optoelectronic measurement technology [11439-110]
- 11439 1S Accurate piston error detection unaffected by tip-tilt error [11439-111]
- 11439 1T **MTF non-redundant distribution for multi-piston errors detection of segmented telescopes** [11439-112]